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APPLICATION NO.		FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/636,161		08/10/2000	SHUMIN WANG	98124X205487	6517
29050	7590	09/23/2002			

PHYLLIS T. TURNER-BRIM, ESQ., LAW DEPARTMENT CABOT MICROELECTRONICS CORPORATION 870 NORTH COMMONS DRIVE AURORA, IL 60504

EXAMINER

UMEZ ERONINI, LYNETTE T

ART UNIT PAPER NUMBER

1765

DATE MAILED: 09/23/2002

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)	SIS				
	09/636,161	WANG ET AL.	フィ				
Offic Action Summary	Examin r	Art Unit					
	Lynette T. Umez-Eronini	1765					
The MAILING DATE of this c mmunication app Period f r Reply	ears on the cover sheet with the c	orrespondenc addres	is				
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely. - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication. - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). - Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b). Status							
1) Responsive to communication(s) filed on							
	s action is non-final.						
3) Since this application is in condition for allowance except for formal matters, prosecution as to the ments is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.							
Disposition of Claims	za panie gadyne, rece eler ri,						
4)⊠ Claim(s) <u>1,3-6,8,9,16-27 and 32-35</u> is/are pending in the application.							
4a) Of the above claim(s) is/are withdraw	vn from consideration.						
5) Claim(s) is/are allowed.	•						
6) Claim(s) <u>1,3-6,8,9 and 16-27</u> is/are rejected.							
7)⊠ Claim(s) <u>32-35</u> is/are objected to.							
8) Claim(s) are subject to restriction and/or Application Papers	election requirement.						
9)☐ The specification is objected to by the Examiner	:						
10) ☐ The drawing(s) filed on is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.							
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).							
11)☐ The proposed drawing correction filed on is: a)☐ approved b)☐ disapproved by the Examiner.							
If approved, corrected drawings are required in reply to this Office action.							
12) The oath or declaration is objected to by the Examiner.							
Priority under 35 U.S.C. §§ 119 and 120							
13) Acknowledgment is made of a claim for foreign	priority under 35 U.S.C. § 119(a)-(d) or (f).					
a) All b) Some * c) None of:							
1. Certified copies of the priority documents have been received.							
2. Certified copies of the priority documents have been received in Application No							
 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 							
14) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).							
a) The translation of the foreign language provisional application has been received. 15) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.							
Attachment(s)							
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449) Paper No(s) 8.	5) Notice of Informal F	r (PTO-413) Paper No(s) Patent Application (PTO-15					
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DETAILED ACTION

Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 1, 3-6, 8, 9, and 16-27 are rejected under 35 U.S.C. 103(a) as being unpatentable over Sasaki et al (US 5.770, 095).

Sasaki teaches a polishing (system for polishing) agent (column 1, lines 6-10) comprising:

- (i) water (column 4, line 53);
- (ii) an oxidizing agent such as H₂O₂ (column 4, line 3-5 and 53);
- (iii) a chemical agent (same as a polishing additive) such as phosphonic acids (column 3, line 49);
- (iv) chemical agents forming a protection film by reacting with a metal include benzotriazole and benzimidazole (column 3, lines 38-45; column 4, lines 50-53; column 8, lines 11-14 and 24), which are examples of applicant's passivation film forming agent; and
 - (v) an abrasive (column 8, lines 5-10 and column 10, lines 10-16 and 43-46).

Sasaki differs in failing to teach in (iii) one polishing additive that increases the rate at which the system polishes at least one layer of the substrate, wherein the polishing additive is selected from the group consisting of pyrophosphates, condensed

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phosphates, di-, tri-, and poly- phosphonic acids, phosphonoacetic acids, and salts thereof, aminoethylethanolamine, polyethyleneimine, amino alcohols, amides, imines, imino acids, nitriles, nitros, thioesters, thioethers, carbothiolic acids, carbothionic acids, thiocarboxylic acids, thiosalicylic acids, and mixtures thereof, **in claim 1**.

Kaufman teaches a variety of optional additives such as stabilizers that are used to promote stabilization of the polishing slurry including oxidizing agents against settling, flocculation and decomposition and examples of a preferred a polishing slurry includes and are not limited to phosphonic acids such as aminotri(methylenephosphonic) acid and 1-hydroxyethylidene-4-diphosphonic acid that are examples of diphosphonic acids as claimed in the present invention (column 6, lines 40-55). Since Kaufman uses the same diphosphonic acids in a polishing slurry as that of the claimed invention, then using Kaufman's polishing additive in polishing a layer on a substrate would inherently increase the rate at which the system polishes at least one layer of the substrate as claimed in the present invention.

Hence, it is the examiner's position that it would have been obvious to one having ordinary skill in the art at the time of the claimed invention to modify Sasaki's phosphonic acid with a diphosphonic acid as taught by Kaufman because both compounds are considered equivalent: they are phosphonic acids. Substituting one for the other would have been obvious for the purpose of promoting stabilization of polishing slurry against settling, flocculating, and decomposing.

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3. Claims 32-35 are objected to as being dependent upon a rejected base claim,

but would be allowable if rewritten in independent form including all of the limitations of

the base claim and any intervening claims. Prior art fails to teach a polishing additive

comprising iminodiacetic acid.

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Lynette T. Umez-Eronini whose telephone number is

703-306-9074. The examiner is normally unavailable reached on the First Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Benjamin Utech can be reached on 703-308-3836. The fax phone numbers

for the organization where this application or proceeding is assigned are 703-972-9310

for regular communications and 703-972-9311 for After Final communications.

Itue

September 20, 2002

BENJAMIN L. UTECH
SUPERVISORY PATENT EXAMINER

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